Art Unit: 2862

when a seventh positive voltage is applied to said buried diffusion region;

an eighth positive voltage is applied to said control gate of a cell

5 to be read;

side.

- a ground potential is applied to a bit line connected to the diffusion region closer to a storage node to be read in said cell; and
- a ninth positive voltage it applied to the selected word line electrode,
- 10 cell data is read with the buried diffusion region as the drain
 - 19. The semiconductor memory device according to claim 22, wherein, when a ground potential is applied to said buried diffusion region;
 - an eighth voltage is applied to said control gate of a cell to be read;
 - a seventh positive voltage is applied to the bit line connecting to the diffusion region closer to a storage made to be read in said cell; and
 - a ninth positive voltage is applied to the selected word line electrode,
- 10 a cell data is read with said buried diffusion region as the source
 - 20. The semiconductor memory device according to claim 15, wherein the control gate electrode of a cell adjacent to the enterior cell is set to a ground potential.

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